



AF/2015  
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Response under 37  
CFR 1.116  
Group AU 2615  
Expedited Procedure

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Takeshi Sawada  
Serial No.: 09/711,415  
Filed : November 13, 2000  
For : SEMICONDUCTOR STORAGE MEDIUM  
Group A.U.: 2615  
Examiner : Gevell V. Selby

I hereby certify that this paper is being  
deposited this date with the U.S. Postal  
Service as first class mail addressed to:  
Assistant Commissioner for Patents,  
Washington, D.C. 20231.

Jay H. Maioli  
Reg. No. 27,213

Date  
December 20, 2004

December 20, 2004  
1185 Avenue of the Americas  
New York, NY 10036  
(212) 278-0400

AMENDMENT AFTER FINAL UNDER 37 CFR 1.116

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action of October 20, 2004,  
Applicant respectfully requests that the application be amended as  
follows.